PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuku OKADA et al.

Application No.: Rule

Rule 1.53(b) Divisional Application of

Application No. 09/820,650 filed

March 30, 2001

Filed: July 14, 2003

Docket No.: 109100.01

For:

THIN FILM FORMATION METHOD BY INK JET METHOD, INK JET APPARATUS, PRODUCTION METHOD OF ORGANIC EL DEVICE, AND ORGANIC EL DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

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2. The references were cited by or submitted to the Office in parent application No. 09/820,650, filed March 30, 2001, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,

James A. Oliff Registration No. 27,075

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JAO:HNS/vvr

Date: July 14, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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Sheet 1	of 1	
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Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DO	OCKET NO. I	APPLICATION NO. Rule 1.53(b) Divisional of Application No. 09/820,650					
INFORMATION DISCLOSURE STATEMENT						Аррис	ation No. (
(Use several sheets if necessary)			APPLICANTS Nobuko OKADA et al.							
			FILING DATE July 14, 2003		GROUP 2861					
U.S. PATENT DOCUMENTS										
EXAMINER INITIAL	DOCUMENT NUMBER	DATE		NAME	3		CLASS	SUB CLASS		
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FOREIGN PATENT DOCUMENTS										
	DOCUMENT NUMBER	r	DATE	COUNTRY			CLASS	SUB CLASS		
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	C.W. Tang et al., Organic electrolumin 21, 1987.	nescen	t diodes, A	american Institute of Phys	ics, Appl. P	hys. Le	tt. 51 (12),	September		
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EXAMINER		DATE CONSIDERED								
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.										
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Date: July 14, 2003